

Electronic Patent Application Fee Transmittal

Application Number:	10718320			
Filing Date:	19-Nov-2003			
Title of Invention:	DYNAMICALLY CONTROLLABLE REDUCTION OF VERTICAL CONTACT DIAMETER THROUGH ADJUSTMENT OF ETCH MASK STACK FOR DIELECTRIC ETCH			
First Named Inventor/Applicant Name:	Chunyuan Chao			
Filer:	Gideon Gimlan/Pam Disney			
Attorney Docket Number:	M-15208 US			
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Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appt issue fee	1501	1	1440	1440
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				1740